

CofC

PATENT  
Attorney Docket No.: SAM-0256  
Customer No.: 29344

UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Sung-Un Kwean, *et al.*  
Serial No.: 09/993,832  
Filing Date: November 6, 2001  
Patent Number: 6,897,153 B2  
Issue Date: May 24, 2005  
Group Art Unit: 1765  
Examiner: Umez Eronini, Lynette T.  
Title: ETCHING GAS COMPOSITION FOR SILICON OXIDE AND  
METHOD OF ETCHING SILICON OXIDE USING THE SAME

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail on the date indicated below in an envelope addressed to Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

7/21/05  
Date

Chelsey Davis  
Chelsey Davis

Certificate of Corrections Branch  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Certificate  
JUL 28 2005  
of Correction

TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following:

1. Petition for Certificate of Correction under 37 C.F.R. § 1.322;
2. Certificate of Correction; and
3. Return Postcard

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date: July 21, 2005  
Mills & Onello, LLP  
Eleven Beacon Street, Suite 605  
Boston, MA 02108  
Telephone: (617) 994-4900  
Facsimile: (617) 742-7774  
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Anthony P. Onello, Jr.  
Anthony P. Onello, Jr.  
Registration Number 38,572  
Attorney for Applicants

JUL 28 2005



PATENT  
Attorney Docket No.: SAM-0256

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Chelsey Davis

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Certificate of Corrections Branch  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PETITION FOR CERTIFICATE OF CORRECTION UNDER 37 C.F.R. § 1.322

Sir:

The patentee of the above-identified patent, through its attorney, hereby petitions for issuance of a Certificate of Correction in the above-identified patent. A certificate is required to correct the error in the claims as follows:

In Column 14, Claim 20, Line 7 insert -- ; -- after "thereof".

JUL 28 2005

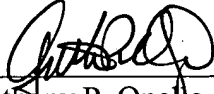
Applicant(s): Sung-Un Kwean, *et al.*  
Serial No.: 09/993,832

It is respectfully requested that a Certificate of Correction be issued to correct the error in the claims.

The correction is not believed to involve such change as would constitute new matter or require examination. Since the error is the fault of the United States Patent and Trademark Office, it is believed that no fee is due.

Respectfully submitted,

Date: July 21, 2005  
Mills & Onello, LLP  
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Boston, MA 02108  
Telephone: (617) 994-4900  
Facsimile: (617) 742-7774  
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Anthony P. Onello, Jr.  
Registration Number 38,572  
Attorney for Applicant

**UNITED STATES PATENT AND TRADEMARK OFFICE**

**CERTIFICATE OF CORRECTION**

**PATENT NO.:** 6,897,153 B2

**DATED:** May 24, 2005

**INVENTOR(S):** Sung-Un Kwean, *et al.*

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

In Column 14, Claim 20, Line 7 insert -- ; -- after "thereof".

**MAILING ADDRESS OF SENDER:**

Anthony P. Onello, Jr.  
Mills & Onello LLP  
Eleven Beacon Street, Suite 605  
Boston, MA 02108

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**PATENT NO. 6,897,153 B2**

**JUL 28 2005**